



Image

1763

Attorney Docket No.: 989_001DIV 1 (now 1153_010 DIV1)

PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon, et al.

Serial No.: 10/004,463

Art Unit: 1763

Filed: November 02, 2001

Examiner: Olsen, Allan W.

Title: **METHOD FOR FABRICATING MEMS AND
MICROFLUIDIC DEVICES USING LATENT MASKING TECHNIQUE**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail addressed to Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 19, 2003.

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NOTIFICATION OF CHANGE OF ATTORNEY DOCKET NUMBER

Sir:

Please take note that the attorney docket number for the patent application identified above has been changed from 989_001DIV 1 to 1153_010DIV 1.

While no fee is believed due with this submission, the Commissioner is hereby authorized to charge any additional fees associated with this submission, or credit any overpayment, to Deposit Account No. 50-0289.

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